



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of: ) Attorney Docket: 4425-154

LAI ET AL.

) Group Art Unit: 2823

Serial No.: 09/888,494

) Examiner: Long Pham

Filed: June 26, 2001

)

For: METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR  
TYPE FIELD EFFECT TRANSISTOR

**AMENDMENT**

Honorable Commissioner for Patents  
Washington, D.C. 20231

Sir:

This paper is in response to the Official Action dated July 9, 2002. In that Official Action, Claims 1-18 are rejected under 35 U.S.C. §103(a). Kindly amend the application in accordance with the following particulars:

103(a)  
with  
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